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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/532,991 Confirmation No. : 2959  
First Named Inventor : Mitsuhiro YUASA  
Filed : April 28, 2005  
TC/A.U. : 2812  
Examiner : Mohsen AHMADI  
  
Docket No. : 101249.56268US  
Customer No. : 23911  
  
Title : Process Monitor and System for Producing Semiconductor

**REPLY**

**Mail Stop AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the non-final Office Action dated February 24, 2006.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.